

# The Mechanical Loss of Thin-Film Hafnia as a Function of Temperature

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# Overview

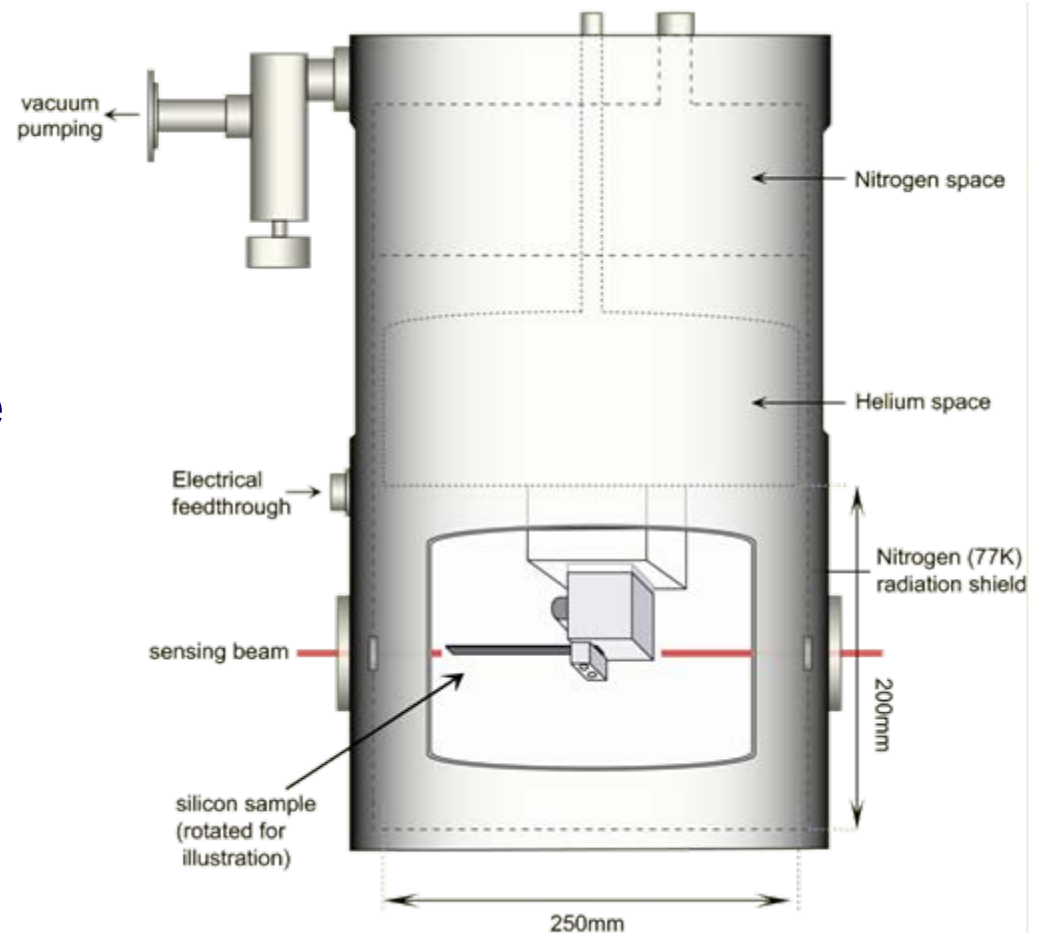
- Introduction: Tantalum and beyond
- Experimental setup
- Measurements of low temperature dissipation in hafnia
- Applications of hafnia as a high index coating
- Calculation of hafnia/silica multilayer coating loss

# Beyond Tantalum Coatings

- The high index coatings required in gravitational wave detector optics have been determined to contribute significantly to detector thermal noise.
- $\text{Ta}_2\text{O}_5$  is the dominant source of dissipation in current coatings – mechanism under investigation.
- $\text{Ta}_2\text{O}_5$  is known to grow with oxygen deficiencies.  $\text{HfO}_2$  is known to have better stoichiometry – alternate high index material.
- Is the dissipation mechanism similar?

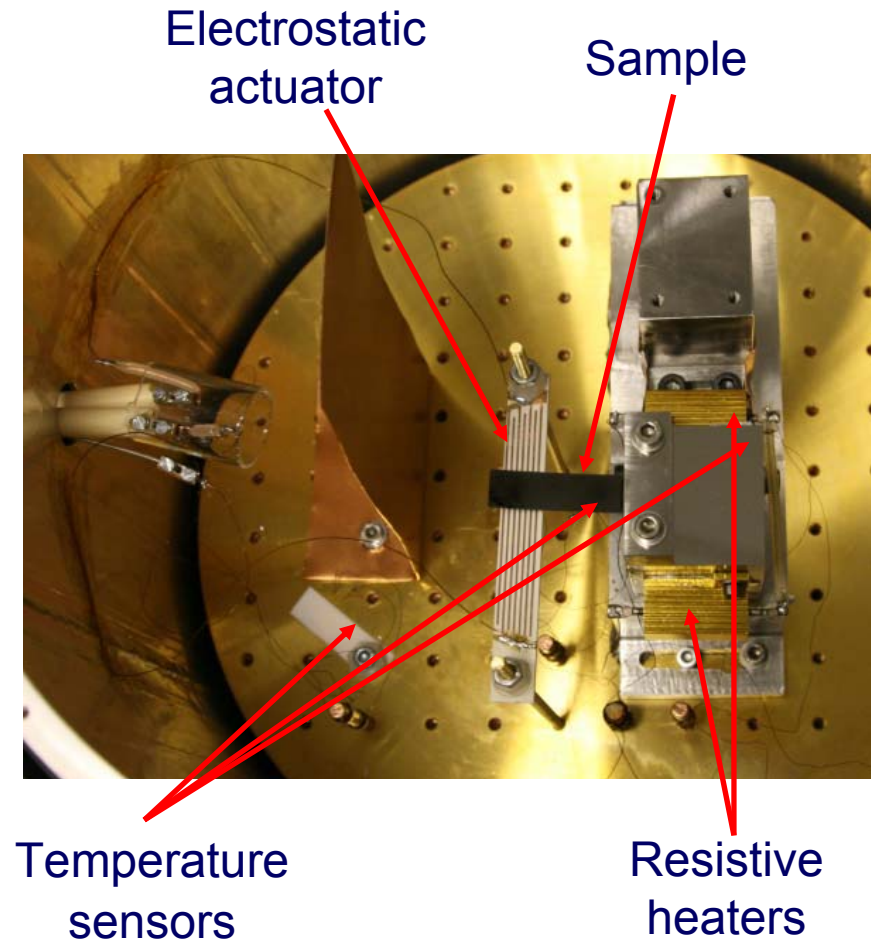
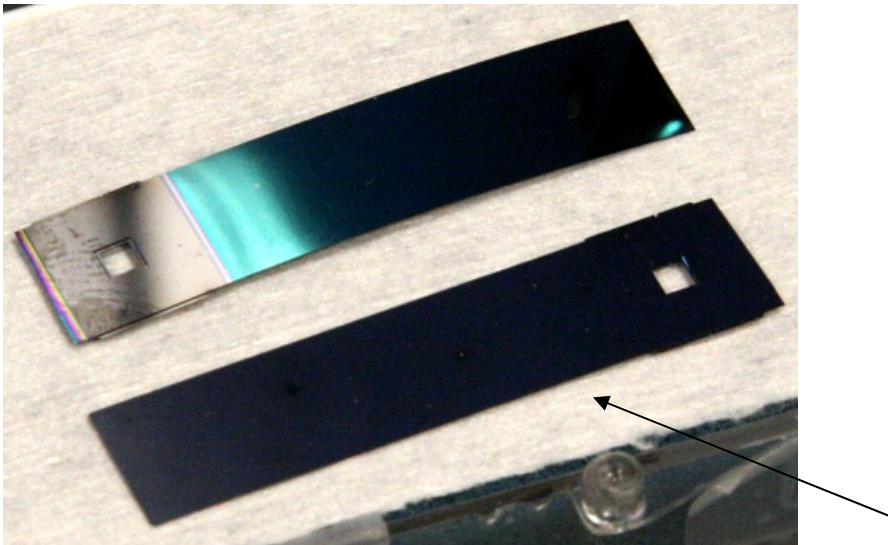
# Cryogenic Mechanical Loss Measurement

- Experimental method – see previous talk.
- Small, lightweight cryogenic system:
  - efficient cryogen use
  - fast cool down
  - good thermal control
- Motion sensed by cantilever shadow – very little variation of beam alignment with temperature.



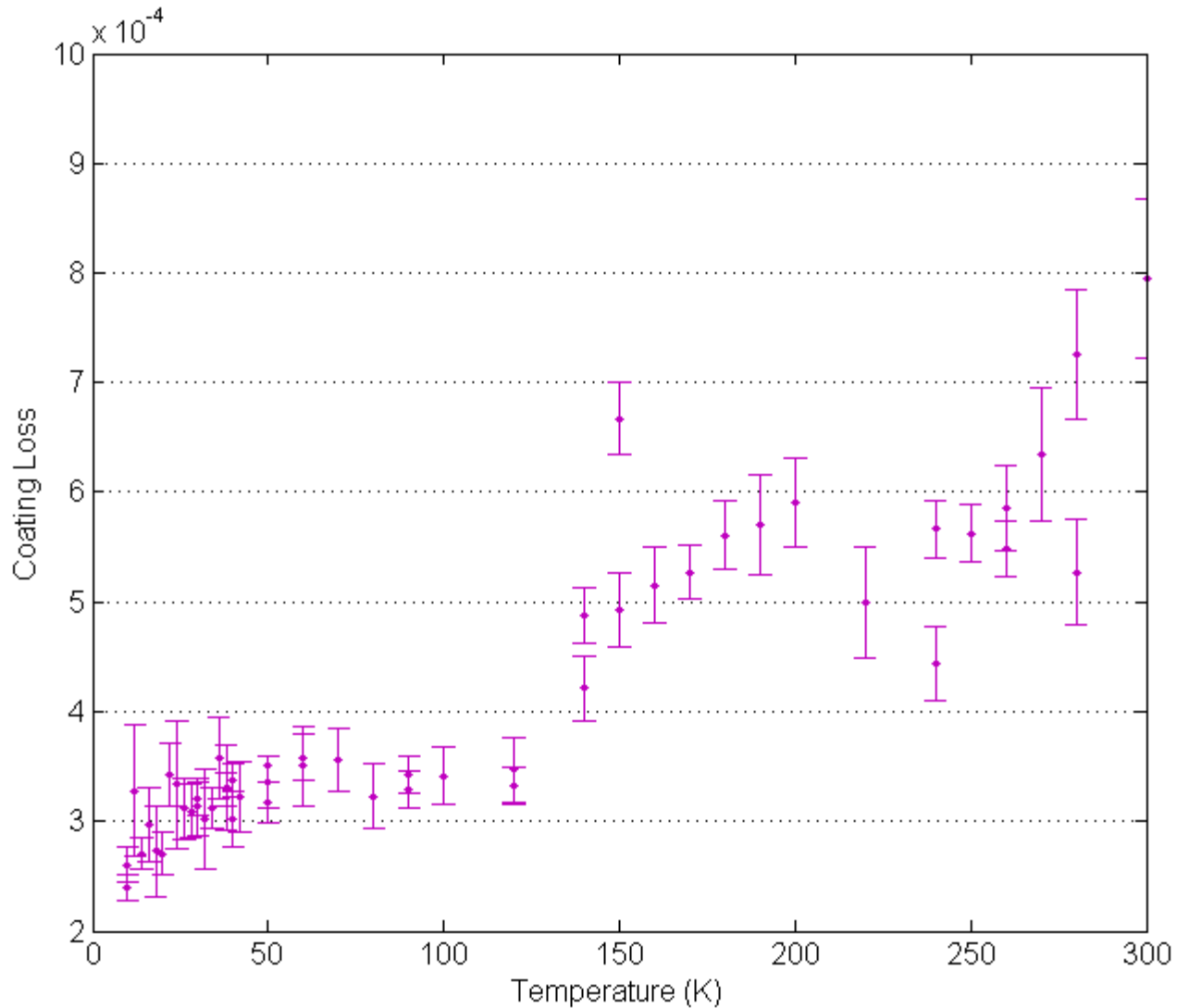
# Cryogenic Mechanical Loss Measurement

- Sample dimensions:
  - Length = 40mm
  - Width = 10mm
  - Substrate thickness = 59.2 $\mu$ m
  - Coating thickness = 500nm

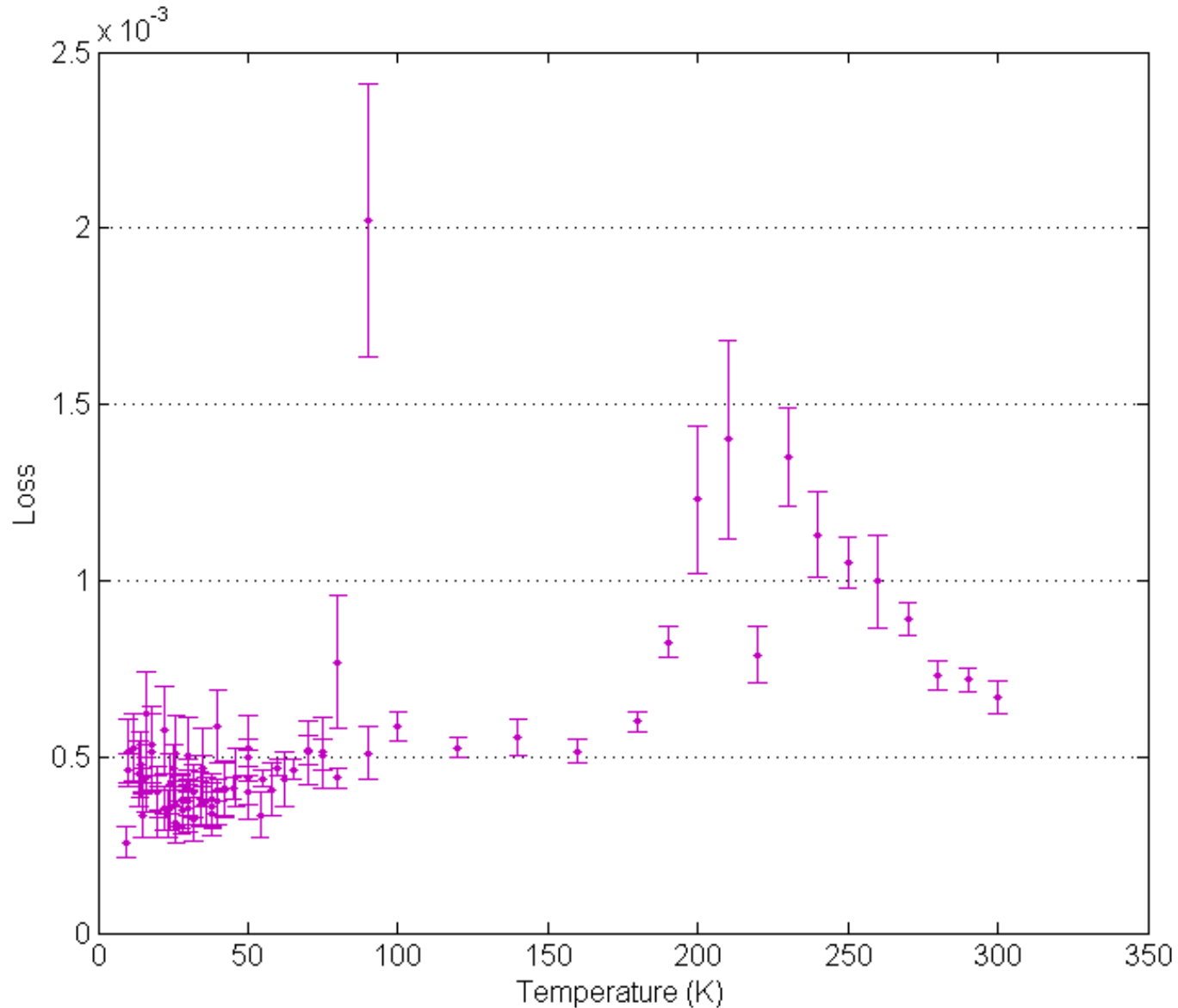


Cantilever substrates fabricated at Stanford and coated by CSIRO

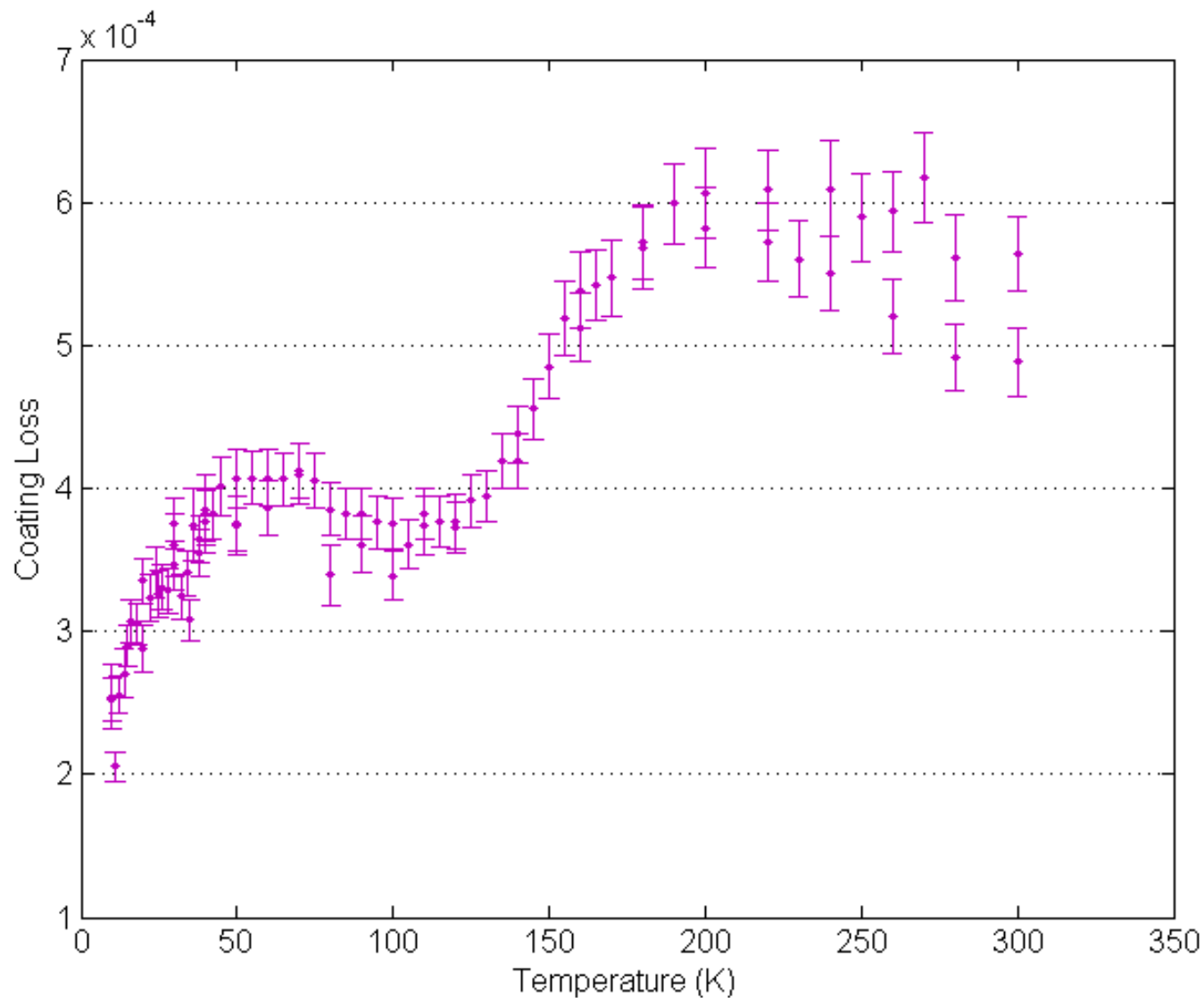
# Temperature Dependence of Coating Loss for Mode at $f = 56\text{Hz}$



# Mode at $f = 330\text{Hz}$

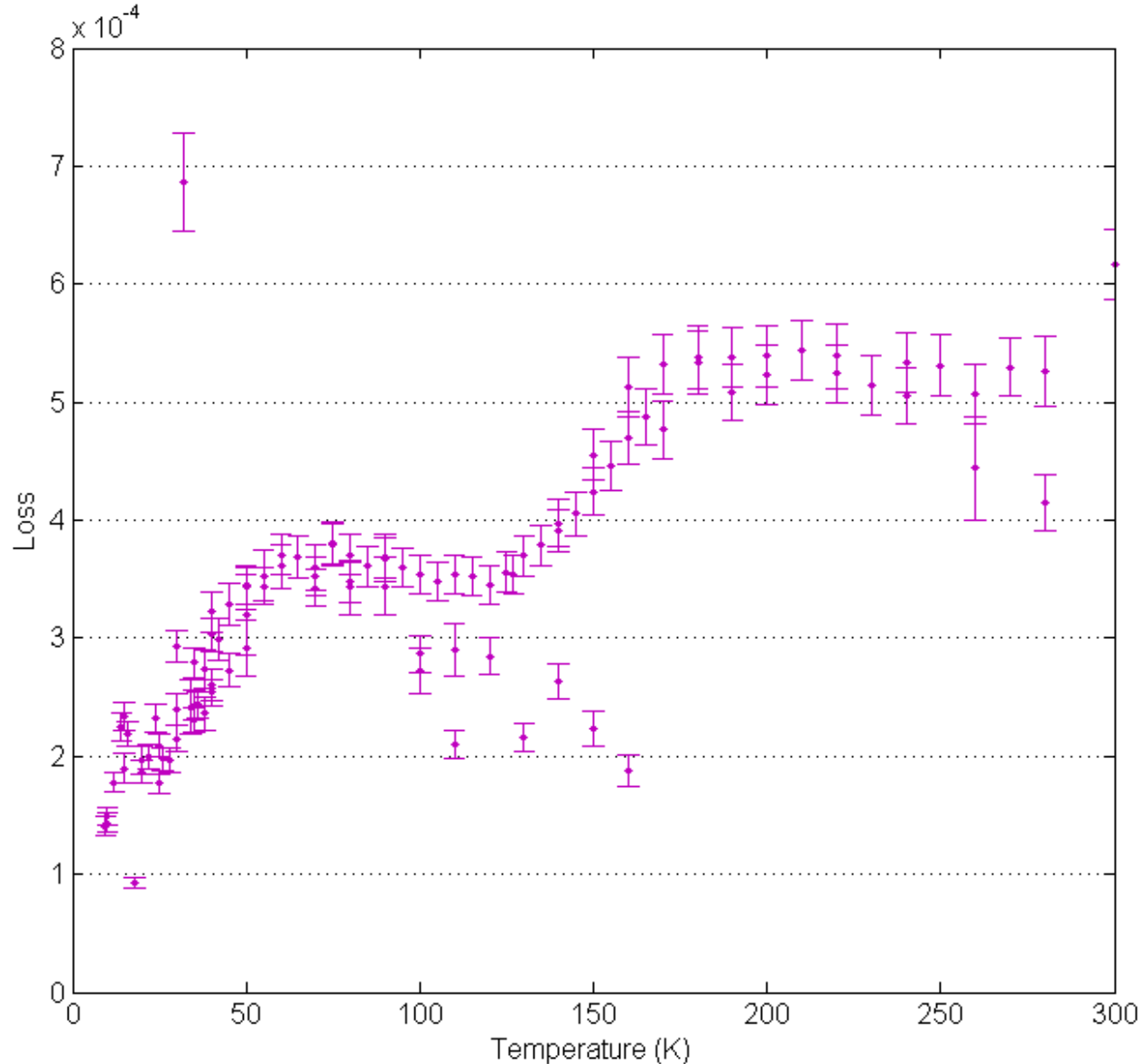


# Mode at $f = 950\text{Hz}$

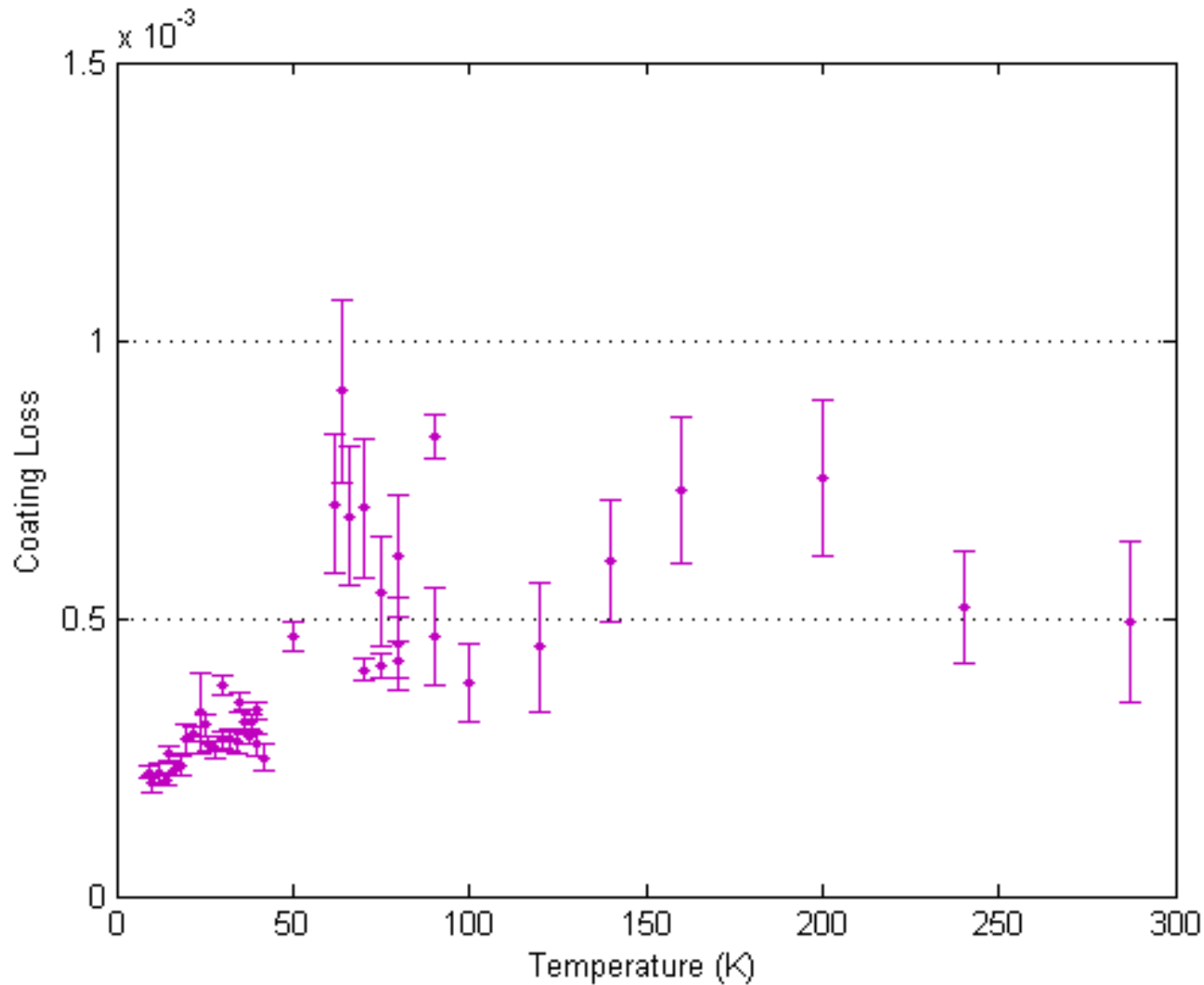




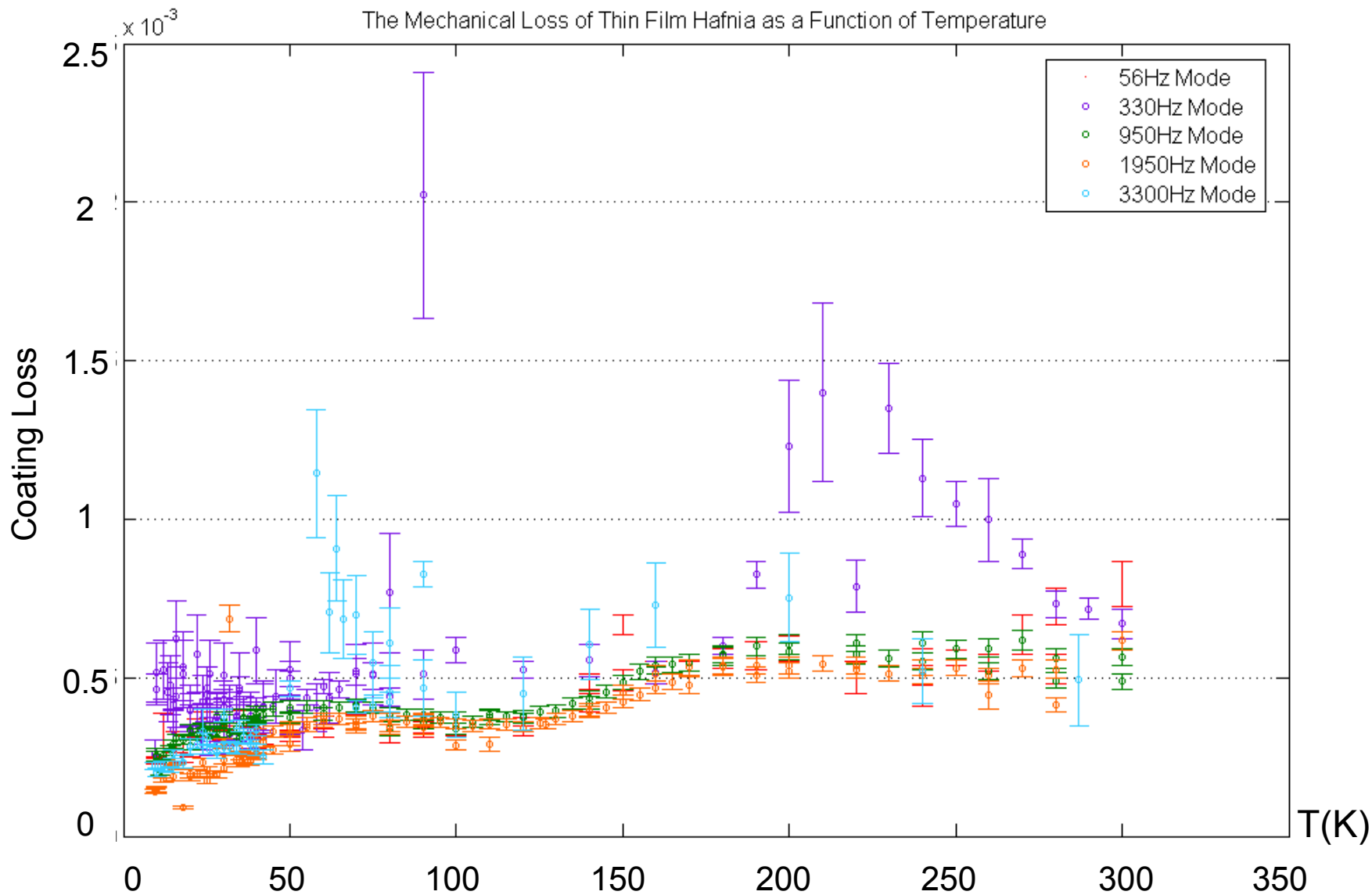
# Mode at $f = 1950\text{Hz}$



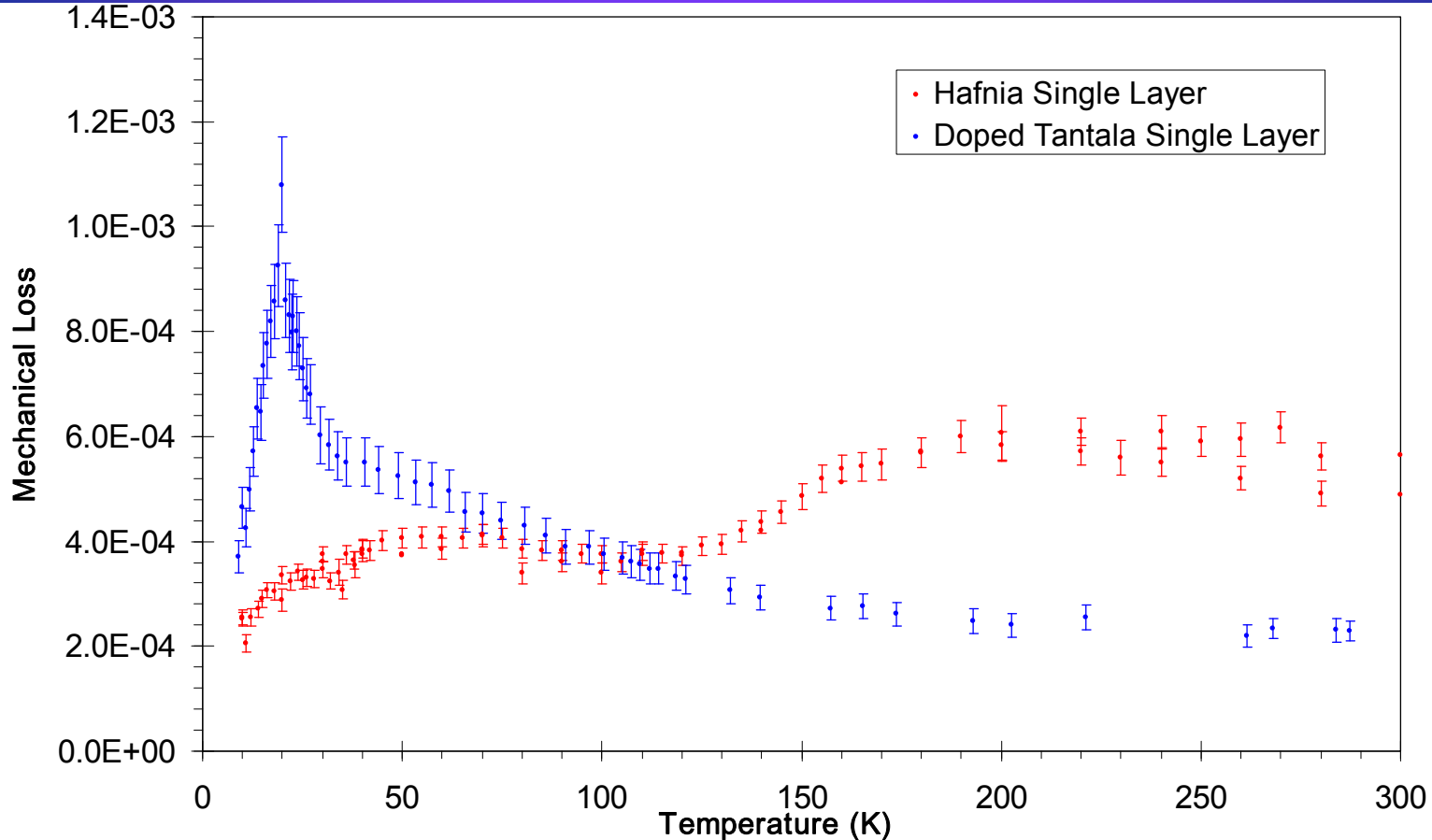
# Mode at $f = 3300\text{Hz}$



# Plot showing coating loss for all modes studied



# Comparison with Tantala

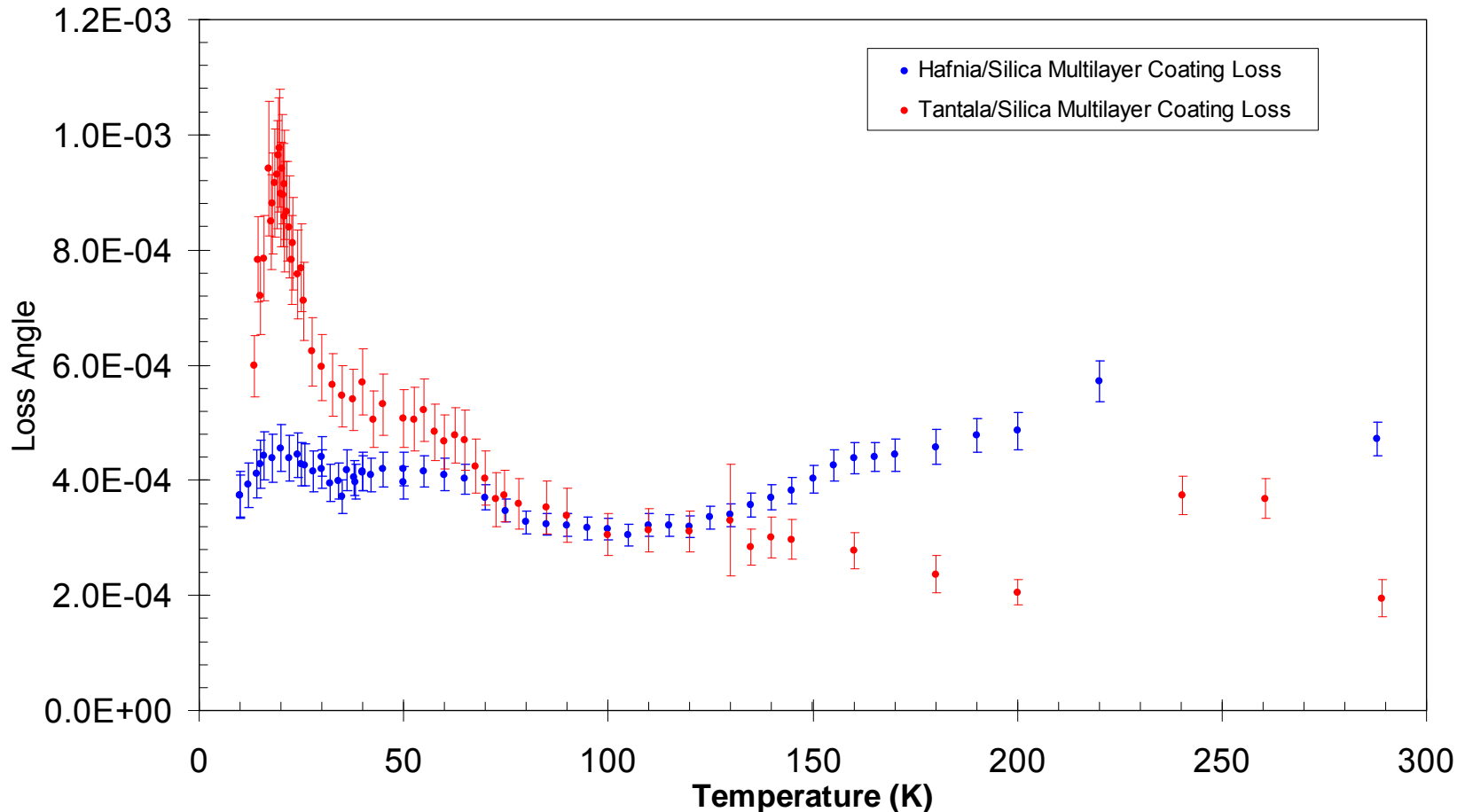


- At 100 K, the level of mechanical loss associated with both doped tantala and hafnia appears at a level  $\phi(\omega)_{\text{coating}} \sim 4 \times 10^{-4}$
- HfO<sub>2</sub> shows **no major** low temperature dissipation peak, loss appears to decrease to below  $3 \times 10^{-4}$  at  $\sim 15$  K.

# HfO<sub>2</sub> as a Coating Component

- Initial results of the mechanical loss of HfO<sub>2</sub> do not show a large peak in dissipation at  $T \sim 20\text{K}$  in **contrast to Ta<sub>2</sub>O<sub>5</sub>**
- Broad peaks do appear to occur at  $\sim 50\text{K}$  and  $\sim 200\text{K}$  – could this indicate a **different dissipation mechanism?**
- Initial room temperature studies on a multi-layer silica-hafnia coating on a fused silica substrate were found to be  $\phi_{\text{hafnia}} = (5.7 \pm 0.3) \times 10^{-4}$

# Calculated Loss of 31-layer Coatings



- above 130K, the silica/tantala coating has a factor of 2 lower loss
- below 70K, the silica/hafnia coating stabilizes at a loss of about 4e-4, with a very slight bump at around 20K, due to the dissipation peak in silica.

# HfO<sub>2</sub> as a Coating Component

- However, thermo-mechanical material properties for ion-beam-sputtered thin-film HfO<sub>2</sub> are not terribly well studied – could change absolute values of the loss results presented here.
- The optical properties also require further investigation, where initial recent absorption studies of a multilayer silica-hafnia coating by Markosyan et al. (Stanford University) lie in the range 60-80ppm, which is considerably higher than required.